

FORM PTO-1449/A and B (Modified)		APPLICATION NO.: 09/940,073	ATTY. DOCKET NO.: H0498/7155
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>		FILING DATE: August 27, 2001	
		APPLICANT: Yang et al.	
		GROUP ART UNIT: 1732 1731	EXAMINER: <del>Not Yet Assigned</del> FIORILLA
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#### U.S. PATENT DOCUMENTS

Examiner's Initials#	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		
CF	38	5,698,485	A1	Bruck et al.	12/16/1997
CF	39	5,958,430	A1	Baldus et al.	11/16/1999
CF	40	5,866,705	A1	Jansen et al.	02/02/1999
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		Office/Country	Number	Kind Code			
CF	42	WO	96/29629 ✓	A2	Whitesides et al.	09/26/1996	yes
CF	43	WO	98/34886 ✓	A1	Schueller et al.	08/13/1998	yes
CF	44	EP	0112721 ✓	A2	Layton et al.	12/21/1983	yes
CF	45	EP	0672765 ✓	A1	Reetz et al.	03/04/1995	yes
CF	46	EP	07237229 ✓		Haruo et al. (Abstract)	12/09/1995	yes

#### OTHER ART — NON PATENT LITERATURE DOCUMENTS

Examiner's Initials#	Cite No	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.	Translation (Y/N)
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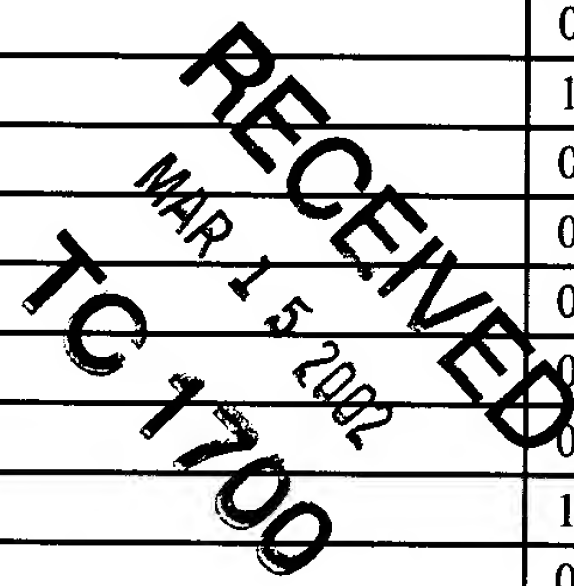
**CHRISTOPHER A. FIORILLA**  
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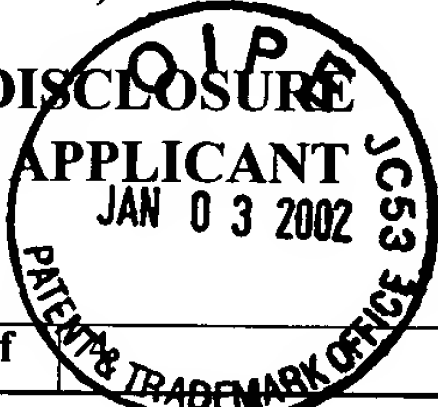
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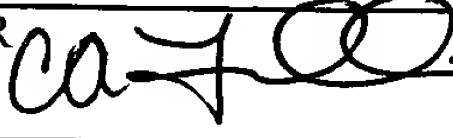
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EXAMINER 	DATE CONSIDERED 2/7/03
<b>CHRISTOPHER A. FIORILLA</b> PRIMARY EXAMINER	

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\*a copy of this reference is not provided as it was previously cited by or submitted to the office in a prior application, Serial No. \_\_\_\_\_, filed \_\_\_\_\_, and relied upon for an earlier filing date under 35 U.S.C. 120 (continuation, continuation-in-part, and divisional applications).

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